## Features

- ▶ 400 Hz high speed scans
- One or two axis motion
- ▶ 2 mrad or 5 mrad ranges of motion
- Mount in any orientation
- > pico sensor technology
- ▶ Closed loop control
- ▶ High Stability

## **Typical Applications**

- High speed laser beam steering
- Optical trapping
- ▶ Interferometry
- ▶ FBG writing
- Optical disk manufacturing
- Astronomy
- Active optics



## **Product Description**

The Nano-MTA Series are single axis and two axis piezoelectric mirror tip/tilt actuators. With nanoradian resolution, the Nano-MTA Series is ideal for applications involving laser beam steering, tracking, and scanning. Internal position sensors utilizing proprietary **pico** technology provide absolute, repeatable position measurement under closed loop control. The Nano-MTA Series is comNano-MTA2X (extended range) constructed from aluminum.

patible with either the Nano-Drive® or Nano-Drive®85 controllers. Both controllers include sensor electronics, proportional integral feedback control, and 150V amplifiers. When used with the high power Nano-Drive®85 controller, the Nano-MTA Series is capable of continuous, high speed scans at 400 Hz and step response times down to 2 milliseconds.



## **Technical Specifications**

Range of motion (per axis)	2.0 mradian
Resolution	4.0 nradian
Range of motion (extended)	5.0 mradian
Resolution	10 nradian
Resonant Frequency - (with 25mm diameter x 3mm	
thick glass mirror)	
X axis (2mrad/5mrad)	3.2kHz/2.8kHz ±20%
Y axis (2mrad/5mrad)	1.25kHz/800Hz ±20%

Scanning Speed ..... up to 400 Hz

- Optics ...... 25mm diameter mirror mounting area\*
- Body Material ..... Al or Invar and Titanium

Controller ...... Nano-Drive® or Nano-Drive®85

\* Mirrors can be attached to the Nano-MTA2 using Milbond adhesive available from Edmund Optics - stock number NT53-288.



Measured position noise of the Nano-MTA2 shows the system's exceptional stability.



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